

## PATENT ASSIGNMENT COVER SHEET

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<b>RECEIVING PARTY DATA</b>	
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## License to the United States Government

Invention Title: Chemical fluid deposition method for the formation of metal and metal alloy films on patterned and unpatterned substrates

Inventor(s): David Long, James J. Watkins, Ph.D., Jason Lazorcik, Jason Blackburn

Patent or Application Serial No.: US 6,689,700

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Foreign Application filed/intended in (countries):

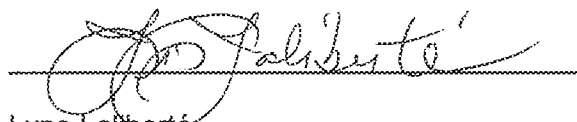
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Signed this 25th day of September, 2014.

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